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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

stitute for form 1449A/PTO

Complete if Known

Application Number 10/632643

Filing Date August 01, 2003

First Named Inventor ROGER HARQUAIL FRENCH

Group Art Unit 1772

Examiner Name

 (use as many sheets as necessary)
 Examiner Name

 Sheet
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 of
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 Attorney Docket Number
 CL2037USCIP

	U.S. PATENT DOCUMENTS								
Examiner Initials *			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant				
mî	_	us -	6,193,952	02-27-2001	Alexey Kabalnov, et al.	Figures Appear			
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	FOREIGN PATENT DOCUMENTS							
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Initials*	No.1	CountryCode ³ Number ⁴ Kind Code ⁵ (if known)	1	Applicant of Cited Document		т,		
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	STATEMENT BY APPLICANT				First Named Inventor	ROGER HARQUAIL FRENCH ET. AL.	
					Group Art Unit	1772	
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/	Sheet 2		of	3	Attorney Docket Number	CL2037USCIP	
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		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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Substitute for form 1449A/PTO Complete if Known **Application Number** 10/632643 INFORMATION DISCLOSURE Filing Date August 01, 2003 STATEMENT BY APPLICANT ROGER HARQUAIL FRENCH ET. AL. First Named Inventor Group Art Unit 1772 (use as many sheets as necessary) **Examiner Name** Attorney Docket Number CL 2037LISCIP

•	Sheet	3	of 3 Attorney Docket Number CL2037USCIP				
	OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS						
	Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
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